HALO QRP

Trace-Level Low-Pressure Moisture Analyzer

GASES & CHEMICALS CEMS ENERGY SEMI & HB LED ATMOSPHERIC LAB & LIFE SCIEN
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Designed for trace level moisture analysis in low pressure (<50 Torr) applications, the HALO QRP offers:

- Detection limit of 1 μ Torr partial pressure H₂O and below
- Absolute accuracy and excellent precision
- Wide dynamic range—over four orders of magnitude
- Low cost of ownership and operational simplicity
- Clean technology—no external calibration gases required
- Compact analyzer footprint, ideal for OEM equipment integration

Protect Your Process with the HALO QRP

Modern semiconductor deposition processes—from low-temperature epitaxy to ALD and MOCVD operate routinely at chamber pressures far below atmosphere and approach the single-digit torr range. At the same time, process temperatures are steadily decreasing. Under these conditions, residual moisture in the chamber poses a significant threat to process quality and production yields.

Tiger Optics' HALO QRP is optimized to operate under these low-pressure conditions and deliver

exact and reliable real-time measurements to verify moisture residue in, for example, the load lock, transfer and process chambers before H₂O contaminants compromise the subsequent process step. Based on Tiger Optics' proven Cavity Ring-Down Spectroscopy (CRDS) technology, the HALO QRP sets new standards in ease-of-use and measurement precision for this application, and operates at chamber pressures as low as 1 Torr.



HALO QRP Trace-Level Low-Pressure Moisture Analyzer

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Tigat Iteration 5.155 Mark	

Performance, H ₂ O Detection		
Operating range	0 – 12 mTorr _{pp}	
	(1200 ppm @ 10 Torr)	
Detection limit (LDL,	1 µTorr _{pp}	
24h peak-to-peak variation)	(see chart below for ppb units)	
Sensitivity (3 o)	0.5 µTorr _{pp}	
	(see chart below for ppb units)	
Precision (1ơ, greater of)	± 1% or 1/3 of Sensitivity	
Accuracy (greater of)	± 5% or 1/2 of LDL	
Speed of response	1 to 2 min (if not flow-limited)	
Environmental conditions	10°C to 40°C	
	30% to 80% RH (non-condensing)	
Storage temperature	-10°C to 50°C	

Gas Handling	System and	d Conditions*
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Wetted materials	316L stainless steel
	(corrosive gas version optional)
	10 Ra surface finish
Gas connections	1/4" male VCR inlet and outlet
	with manual shut-off valves
Leak tested to	1 x 10 ⁻⁹ mbar l / sec
Inlet pressure ⁺	1 – 1000 Torr
Outlet pressure	<20 mTorr (0.027 mbar)
Sample gases§	N ₂ , H ₂ , HCl, Ar (standard)
	He, Cl ₂ (optional)
Gas temperature	Up to 60°C (in detection cell)

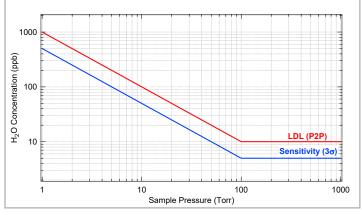
*Vacuum source required

[†]Pressure requirements for moisture measurement – for gas purge in standby mode, inlet pressure limit is 15 psig (1500 Torr) [§]HCl and Cl₂ sample gases may require corrosive gas version, please contact us for more information.

Contact us for additional analytes and matrices. U.S. Patent # 7,277,177

Dimensions	H x W x D [in (mm)]
Standard sensor	8.73 x 8.57 x 26.4 (222 x 218 x 670)
(incl. shutoff valves)	
Sensor rack	8.73 x 19.0 x 26.4 (222 x 483 x 670)
(fits up to two sensors)	
Weight	
Standard sensor	30 lbs (13.6 kg)
Electrical and Interfaces	
Platform	Max series analyzer
Alarm indicators	2 user programmable
	1 system fault
	Form C relays
Power requirements	90 – 240 VAC, 50/60 Hz
Power consumption	40 Watts max.
Signal output	Isolated 4–20 mA
User interfaces	5.7" LCD touchscreen
	10/100 Base-T Ethernet
	USB, RS-232, RS-485
	Modbus TCP (optional)
Data storage	Internal or external flash drive
Certification	CE Mark

Detection Limit and Sensitivity in Concentration Units (ppb)



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